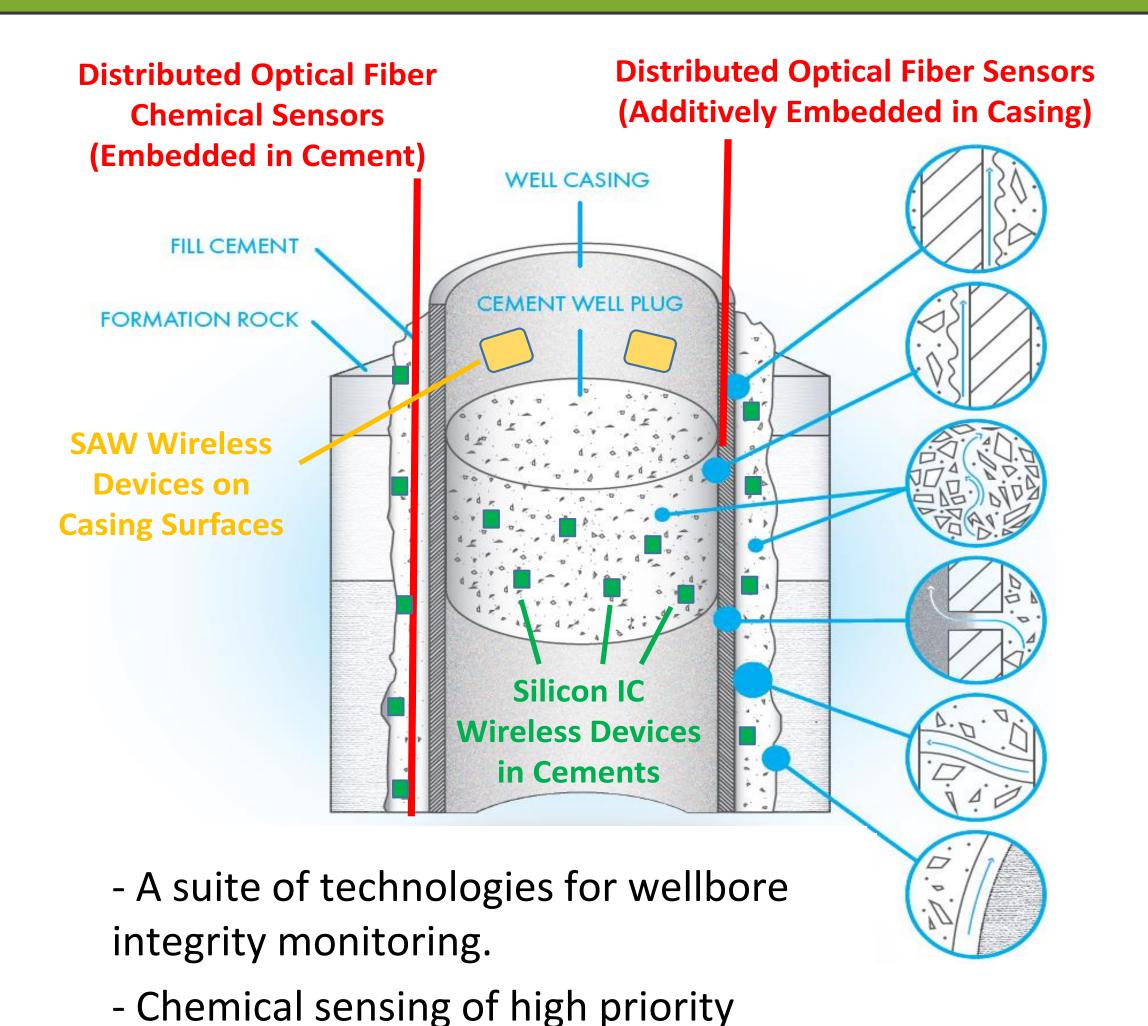
# **Embedded Sensor Technology Suite for Wellbore Integrity Monitoring**

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Research & **Innovation Center** 



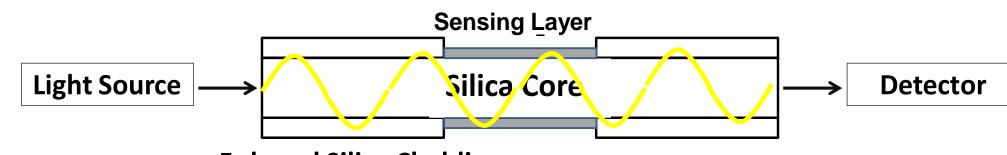
## **Project Overview**



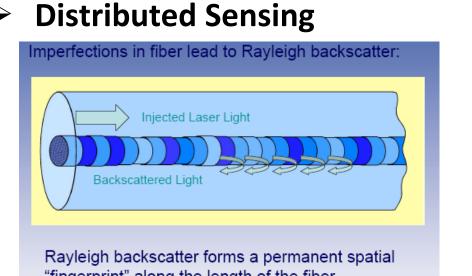
## Distributed Fiber Optic Based Chemical Sensors

#### Chemical/pH Sensing Layers (NETL)

**Sensing Principle: Evanescent Wave Sensors** 

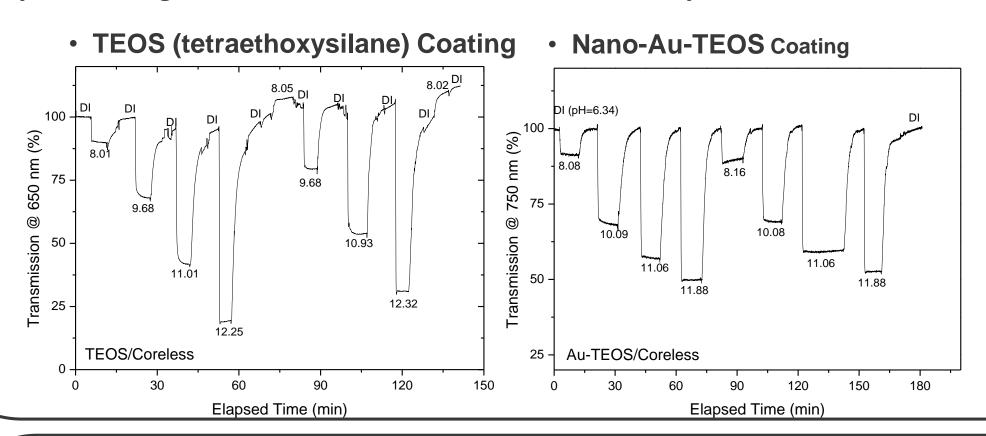


F-doped Silica Cladding

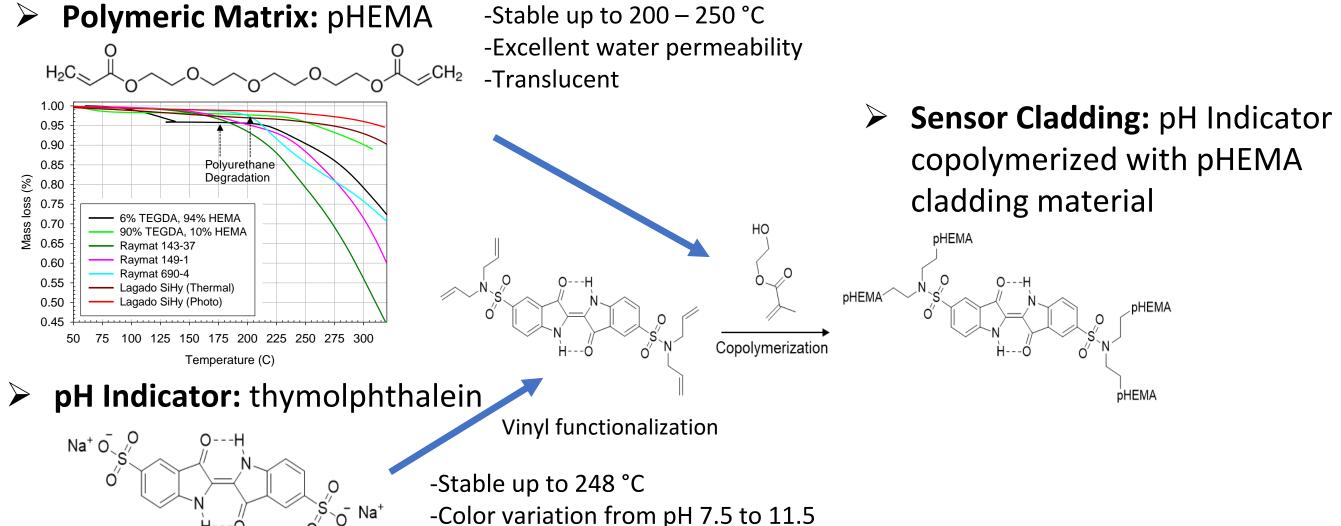


- → Eliminate Electrical Wiring and **Contacts at the Sensing Location**
- → Tailored to Parameters of Interest **Through Functional Materials**
- → Compatibility with Broadband and Distributed Interrogation

pH sensing materials: TEOS and Nano-Au incorporated-TEOS



## Organic pH Sensitive Coating Fabrication/Deployment (IOS)







-Accelerated curing process < 60s -Moderate curing temperature 100 °C or photocuring -Controlled pre-polymer viscosity for uniform coating distribution

In-line fiber recoating of long fiber optic sensors

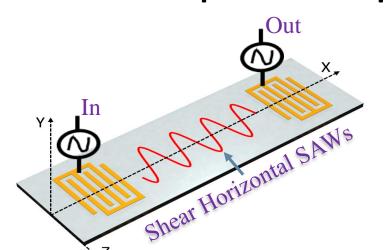




## Passive, Wireless Surface Acoustic Wave (SAW) Sensors (NETL & CMU)

parameters (pH, corrosion onset, etc.)

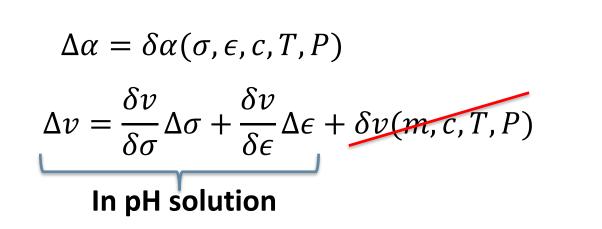
> SAWs for Liquid Phase Application



**NETL's SAW Devices:**  $f_0 = 520 \text{ MHz}$ Substrate: 36 Y-X LiTaO3 IDTs: Al or Au

**Simulation and Experimental Results** req(51)=5.0051E8 Hz Surface: v\*cos(126\*pi/180)+w\*sin(126\*pi/180) (m) Surface: Pressure (Pa) Water

 $\succ$  SAW Attenuation ( $\alpha$ ) and Velocity (v):



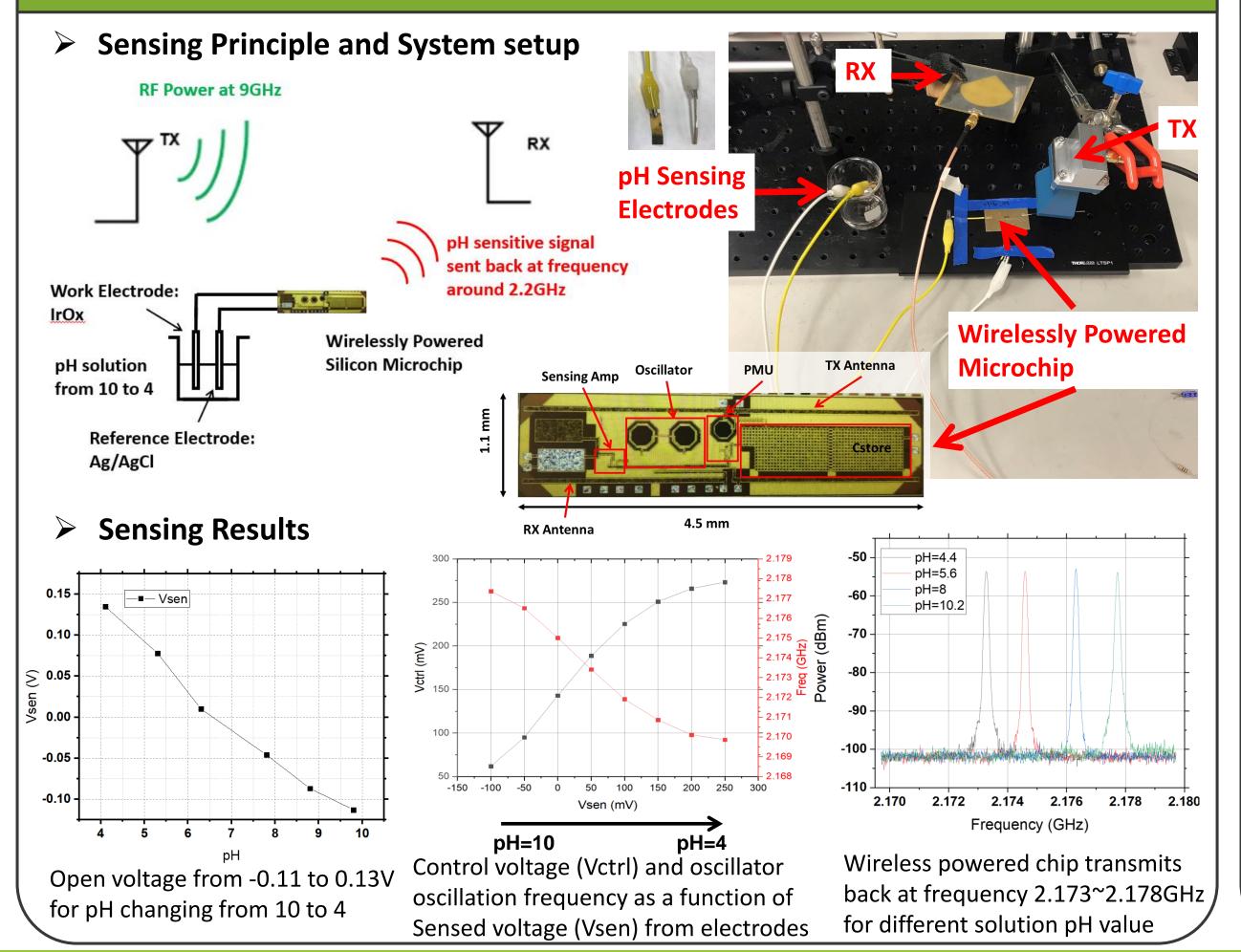
Reflector (Au/Al) IDT (Au/Al) 36 Y-X LiTaO<sub>3</sub> **Delay Line** —— Air (Test Start) DI Water (pH 6.27) - pH 8.0 – pH 11.2 —— pH 6.0 — Air (Test End)

> Measure  $\Delta v$  in terms of time delay.

1.4 1.5 1.6 1.7 1.8 1.9 2.0 2.1 2.2

Time (us)

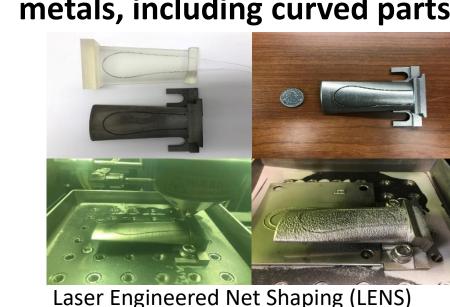
## Passive, Wireless Silicon Integrated Circuit Sensors (UCLA)



## **Embedding of Sensors in Cement and** Casing Materials (NETL & U Pitt)

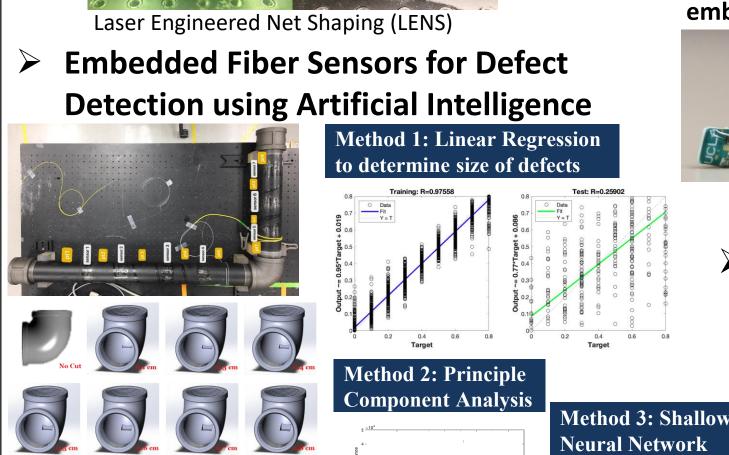
Thermal-curing setup

**Embed fibers in high temperature** metals, including curved parts.



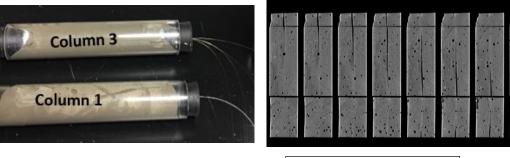
**Defects** 

Normal

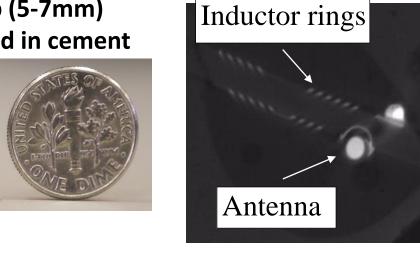












Mechanical testing of cement with sensors embedded





